

Applicants:

T. KAJI, et al.

Application No.:

10/052,538

Filed:

January 23, 2002

For:

PLASMA PROCESSING APPARATUS PROCESSING

METHOD

Art Unit:

1763

Examiner:

A. M. Crowell

<u>AMENDMENT</u>

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 September 20, 2005

Sir:

In response to the Office Action dated May 20, 2005, the period of response for which extension is requested by the attached Petition for Extension of Time, please amend the above-identified application as listed below and set forth on the following pages:

Amendments to the Claims and

Remarks are included following the amendments.

09/22/2005 HALI11

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01 FC:1202 02 FC:1201

550.00 OP

200.00 DP